

Docket No.: 2336-183



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :  
Inventor(s): HONG, Yoon Shik et al. : Confirmation No. 3649  
U.S. Patent Application No. 10/606,348 : Group Art Unit: 2874  
Filed: June 26, 2003 : Examiner:  
For: MICROELECTROMECHANICAL SYSTEMS (MEMS) VARIABLE OPTICAL  
ATTENUATOR

**INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450


Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

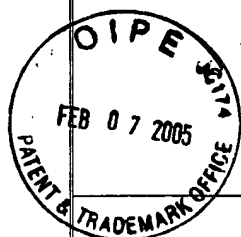
This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

Respectfully submitted,

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**Date: February 7, 2005**



**INFORMATION DISCLOSURE  
CITATION IN AN  
APPLICATION  
(PTO-1449)**

ATTY. DOCKET NO.  
**2336-183**

U.S. PATENT  
APPLICATION NO.  
**10/606,348**

APPLICANT  
**HONG, Yoon Shik et al. et al.**

FILING DATE  
**June 26, 2003**

GROUP  
**2874**

**U.S. PATENT DOCUMENTS**

EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
	<b>6,222,656</b>	<b>4/2001</b>	<b>Eu</b>			

**FOREIGN PATENT DOCUMENTS**

EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						Yes	No

**OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)**


EXAMINER

DATE CONSIDERED

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.